

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/602,468

PATENT

Filing Date: June 23, 2003

Attorney Docket No. 101453-00103

Inventor(s): Venkat SELVAMANAICKAM

SP#156/157

Group Art Unit: 1734

Examiner Name: Not Yet Assigned

Customer No.: 026304

Title: METALORGANIC CHEMICAL VAPOR
DEPOSITION (MOCVD) PROCESS AND
APPARATUS TO PRODUCE MULTI-LAYER
HIGH-TEMPERATURE
SUPERCONDUCTING (HTS) COATED TAPE

Mail Stop _____

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REQUEST TO MAKE SPECIAL

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By: _____



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